

FORM PTO 1449 (modified)		ATTY DOCKET NO. 35.C15518	APPLICATION NO. 09/895,464				
U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		APPLICANT Tohru Den et al.					
LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)		FILING DATE July 2, 2001	GROUP N.Y.A.				
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
<i>JL</i>		6,214,738B1	04/10/01	Aiba et al.	438	707	
<i>JL</i>		6,139,713	10/31/00	Masuda et al.	205	206	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
<i>JL</i>	JP	11-224422	08/17/99	Japan			Abstract
<i>JL</i>	JP	10-121292	05/12/98	Japan			Abstract
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
<i>JL</i>		Hideki Masuda et al., "Fabrication of a One-Dimensional Microhole Array by Anodic Oxidation of Aluminum," 63(23) Appl. Phys. Lett. 3155-3157 (1993).					
<i>JL</i>		H. Masuda, 31(5) Solid State Physics 493-499 (1996).					
<i>JL</i>		R.C. Furneaux et al., "The Formation of Controlled-Porosity Membranes From Anodically Oxidized Aluminum," 337 Nature 147-149 (1989).					
<i>JL</i>		Hideki Masuda et al., "Fabrication of Gold Nanodot Array Using Anodic Porous Alumina as an Evaporation Mask," 35(2) Jpn. J. Appl. Phys. 35(2) L126-L129 (1996).					
EXAMINER	<i>Knap (Dinh)</i>			DATE CONSIDERED	<i>12/8/01</i>		

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet 1 of 1

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